Amendments to the Claims

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims

- 1-16 (canceled).
- 17. (New) A semiconductor device comprising:
- a semiconductor substrate optionally personalized with electronic devices formed thereon;
 - at least one copper interconnect pad formed on said substrate; and
- a layer of a zinc complex formed on said at least one interconnect pad, wherein said complex comprises:

copper ion,
zinc ion,
an organic acid and

an azole.

- 18. (New) The semiconductor device, according to claim 17, wherein said zinc complex further comprises a surfactant.
- 19. (New) The semiconductor device, according to claim 17, wherein said zinc complex further comprises an amine.
- 20. (New) The semiconductor device, according to claim 17, wherein said zinc complex further comprises a complexing agent.
- 21. (New) The semiconductor device, according to claim 17, wherein the molar ratio of said zinc ion to said azole is from about about 1:1 to about 2:1.

- 22. (New) The semiconductor device, according to claim 17, wherein said azole is benzotriazole.
- 23. (New) The semiconductor device, according to claim 18, wherein said surfactant is a nonionic surfactant.
- 24. (New) The semiconductor device, according to claim 23, wherein said surfactant is selected from the group consisting of SANDOPAN ECO and Triton DF16.
- 25. (New) The semiconductor device, according to claim 17, further comprising ammonia.
- 26. (New) The semiconductor device, according to claim 20, wherein said complexing agent is triethanolamine.
- 27. (New) The semiconductor device, according to claim 17, wherein said organic acid is acetic acid.
- 28. (New) The semiconductor device, according to claim 17, wherein said zinc complex layer is deposited from a solution comprising:
- at least one azole present at a concentration of from about 0.001 to about 0.5 molar;
 - a zinc salt having present at a concentration of from about 0.1 to about 1 molar; an organic acid; and
 - a complexing agent, and wherein
 - the pH of said solution is from about 5 to about 8.
- 29. (New) The semiconductor device, according to claim 17, further comprising a layer of a solder applied to said zinc complex layer.